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Docket: 0756-1614

614 2nd Super # 22 IDS 4-6-98 MR

## **CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on March 17, 1998

Cameron S. Gillion

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Takeshi FUKUNAGA et al.

Serial No. 08/781,920

) RECEIVED

MAR 2 7 1998

(a) Art Unit: 1112

Filed: December 30, 1996 ) Examiner: M. Padgett

For: METHOD OF MANUFACTURING )

A SEMICONDUCTOR DEVICE ) Date: March 17, 1998

## SECOND SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents Washington, D.C. 20231

Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the reference listed on the attached Form PTO-1449 be made of record in the above-identified application.

This reference was cited in the Information Disclosure Statement for the subject application, filed March 5, 1998, but a copy of the reference was not

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available at that time. The undersigned now submits a copy of the attached reference in order to complete the Information Disclosure Statement.

A copy of the reference is submitted herewith in accordance with 37 C.F.R. 1.98(a).

Respectfully submitted,

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